



1K AF  
MAIL STOP AF  
PATENT  
8075-1055

**IN THE U.S. PATENT AND TRADEMARK OFFICE**

In re application of

Tadahiro OHMI et al.

Conf. 2418

Application No. 09/889,269

Group 1794

Filed March 5, 2002

Examiner A. Chevalier

METAL MATERIAL HAVING FORMED THEREON CHROMIUM  
OXIDE, PASSIVE FILM AND METHOD FOR PRODUCING  
THE SAME, AND PARTS CONTACTING WITH FLUID AND  
SYSTEM FOR SUPPLYING FLUID AND EXHAUSTING GAS

**RESPONSE AFTER FINAL REJECTION**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

June 19, 2008

Sir:

The following is responsive to the Official Action  
mailed March 21, 2008.

**Remarks** begin on page 2 of this paper.